

Application Data Sheet**Application Information**

Filing Date:: 4/1/2005 12:00:00AM
Application Type:: Regular
Subject Matter:: Utility
CD_ROM or CD-R?: None
Title:: NEAR-FIELD LIGHT GENERATING METHOD,
NEAR-FIELD EXPSOURE MASK, AND NEAR-FIELD
EXPOSURE METHOD AND APPARATUS
Attorney Docket Number:: 00684.103107.
Request for Early Publication:: No
Request for Non-Publication?: No
Total Drawing Sheets:: 6
Small Entity?: No
Petition included:: No
Secrecy Order in Parent Appl.?: No

Applicant Information

Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Natsuhiko
Family Name:: MIZUTANI
City of Residence:: Tokyo
Country of Residence:: Japan
Primary Citizenship Country:: Japan
Given Name:: Tomohiro
Family Name:: YAMADA
City of Residence:: Yokohama-shi

Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 5514

Representative Information

Representative Customer Number::	05514
----------------------------------	-------

Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National stage of	PCT/JP2004/014445	09/24/2004

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-334610	09/26/2003	Yes

Assignee Information

Assignee name:: CANON KABUSHIKI KAISHA
Street of mailing address:: 3-30-2 Shimomaruko, Ohta-ku,
City of mailing Address:: Tokyo
Country of mailing address:: Japan